

isQED 2002

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„Tomorrows High-quality SoCs Require High-quality Embedded Memories Today“

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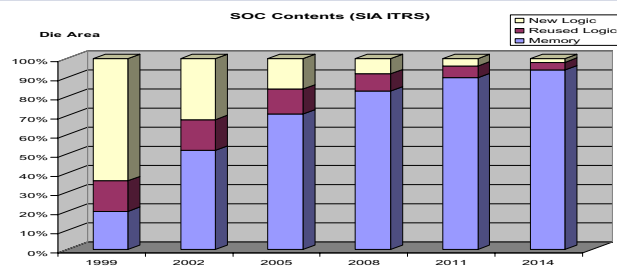
Goal and Outline

IC designers: awareness of memory challenges

Memory designers: no surprises, hopefully!

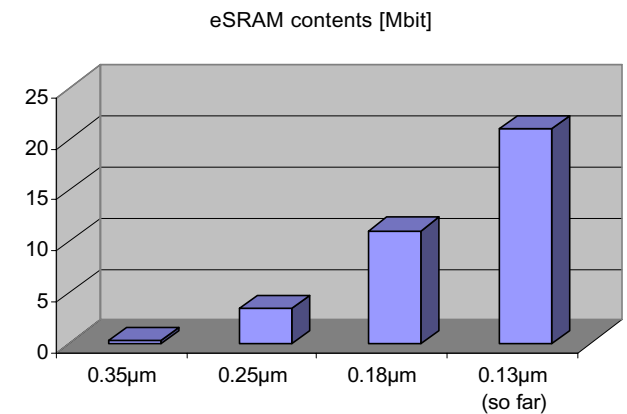
- Dominance of embedded Memories
- Memory Design Challenges
- Manufacturability
- Reliability
- SoC Design Support

If Memory Does not Dominate Your Design Today, It Will Very Soon



- Manufacturing Cost (area, yield, wafer cost)
- Dynamic and leakage power consumption
- Performance
- UDSM effects (IR-drop, EM, leakage (gate!), well proximity, ...)
- Time-to-tapeout
- Time-to-volume

Maximum eSRAM content per IC at IFX



8-Channels ADSL Chip

Complexity: 36.7 mil transistors
1.2 million logic gates

Area: 94.8 mm² (0.18µm C10N)

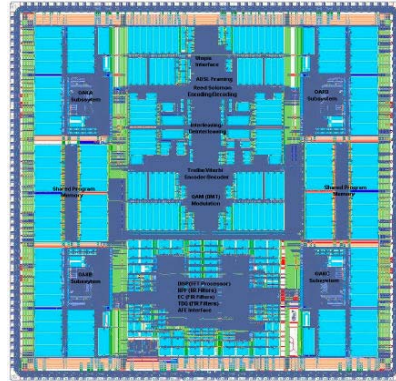
SRAM: 4.6 Mbit (400 macros!!)

DSP: 4 Oak's

MIPS: 5000 MIPS(Oak) ++
+ Trellis/Viterbi

Clock domains: 11 independent clks
~ 200 dependent clocks

Frequency: 150/120 MHz (2 PLL's)



IWORX: Interworking Controller for 3G Mobile Base Station

Application:

ATM Line Card Controller for
"Next Generation (3G) Mobile
Infrastructure (UMTS Base Stations)"

Package: BGA388

Process: 0.18 µm CMOS
6 Layer Metal (fat)

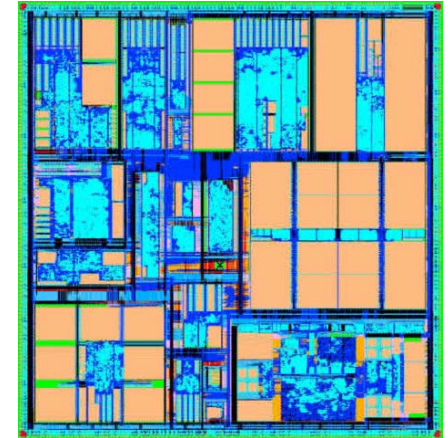
Chip Area: 193.7 mm²
13.72 mm x 14.12 mm

Transistors: ~ 80 Mio.

Gate Count: ~ 2.250.000
(including Tricore™)

SRAM: 11 Mbit (140 macros)

Test Concept: Full Scan Path
63 Chains x ~2000 FF
MemoryBIST



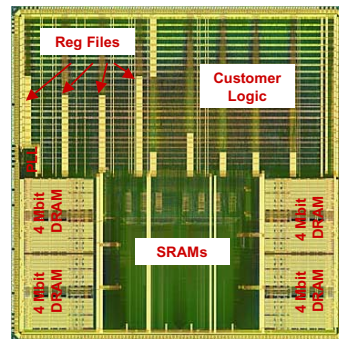
Embedded DRAM Networking Switch Chip

Complexity: 850k logic gates

Area: 117 mm² (0.20µm C9DD1)

Memory: 16 Mbit DRAM (4 Macros)
460 k SRAM
59 Register Files
(241k total)

Frequency: 100 MHz (1 PLL)



Memory Landscape changed dramatically over the last 10 years

Challenges

- SRAM/ROM, eDRAM, 1T, NVM,
=> integrated on SoC
- SoC vs. SiP
- Varied types, e.g. RFs, CAMs, ...
- New design for each generation
- > 15 EDA models; very high accuracy
- UDSM: Leakage; IR drop; EM; X-talk
- Tight coop. Design <==> TD / Fab
- Silicon Qualification essential

- Mostly SRAM
- Types: SP, DP, ROM
- Memories on shrinkpath
- Few EDA models
- Verification on Silicon

1990

2002

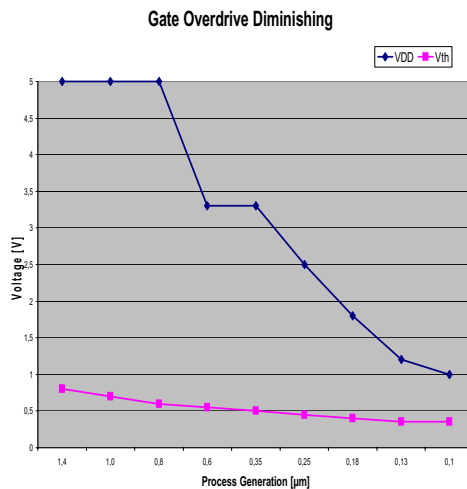
A high-quality Embedded Memory ...

- meets requirements specifications
- can be manufactured with high yield at low cost
- can be tested economically
- meets reliability criteria
- enables timely product design

A high-quality Embedded Memory ...

- **meets requirements specifications**
 - area
 - performance
 - active power
 - standby power
 - correct and accurate EDA modeling
 - functionality
- can be manufactured with high yield at low cost
- can be tested economically
- meets reliability criteria
- enables timely product design

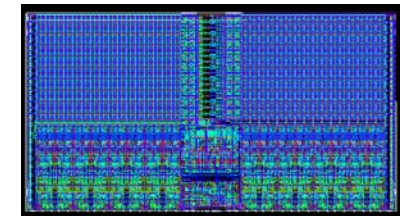
UDSM Process Technologies result in major challenges



- **Dramatically increasing junction leakage**
- **Gate leakage**
- **Relative manufacturing variations increasing**
- **Dominance of wiring delays**

Key Issues in Excellent Memory Design

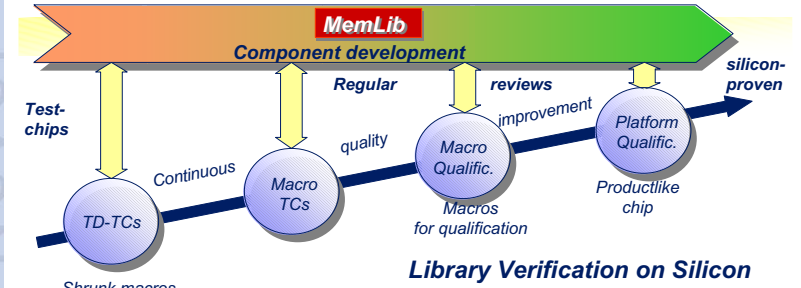
- **Bit Cell**
 - As small as possible (DR waivers)
 - Tradeoff area / leakage / performance
 - Electrically robust
 - Tuned for the specific target fab
 - Running in high volume
- **Architecture**
 - Low Leakage / High Speed
 - Active Well / Virtual Rail
 - Global / Local Bitlines
 - Multi-Banking
 - Timing Control Circuitry
 - Compiler-Optimized
 - Redundancy
- **Sense Amplifier**
 - Voltage / Current Sensing
 - Robustness analysis (sensitivity, MC)
 - Layout critical (matching)
- **Macro Layout**
 - Power Routing: IR Drop, EM, Size Power-ring
 - Crosstalk
 - DfM rules (incl. DRC runsets)



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Excellent **Quality Assurance** - escorting the entire Development

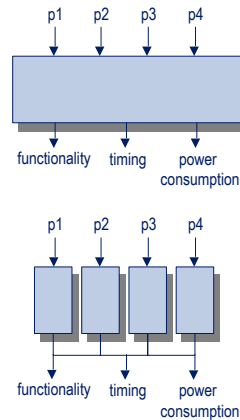


Semi-Custom Test Chip: TCQ-P (Test Chip for Qualification of Platform)

Parts similar to product

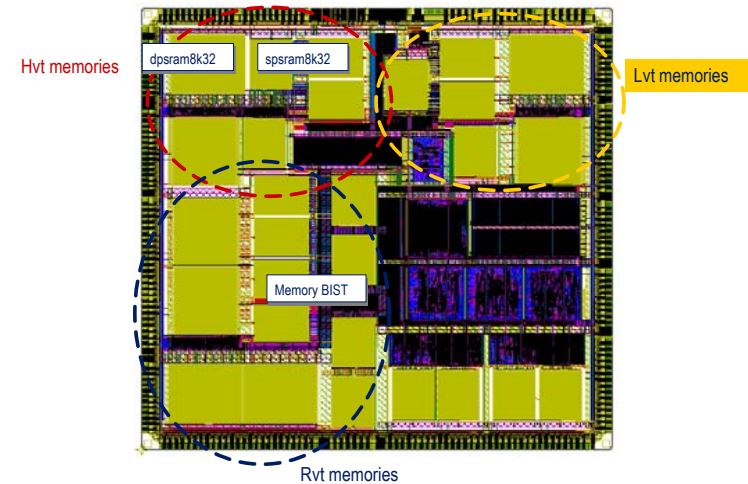
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Parts for low level analysis



Qualification - not just verification

TCQP - Test Chip for Qualification of Platform



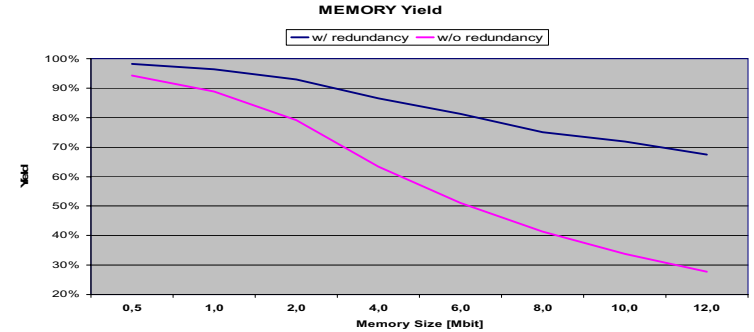
Memories, Testchips Must be Designed for Analyzability

- Probe Points
- Bitmap capabilities
- Programmable Timing Control (Read Margin)
- S/H Measurements possible
- etc.

- Rapid analysis and yield ramp-up depend on
 - Robust design
 - Design-for-Analysis techniques
 - Tight Cooperation between Design, Manufacturing and Analysis

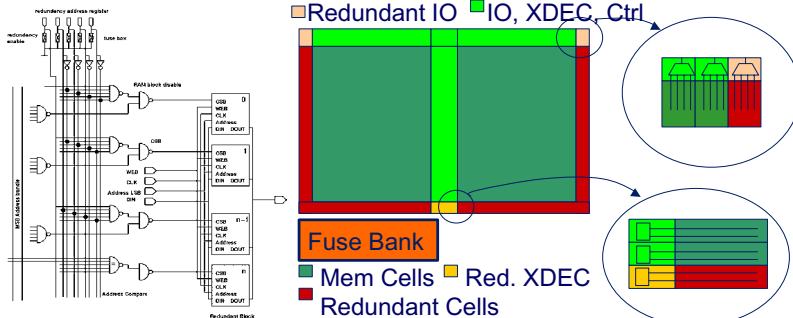
Manufacturing: High Yield & Low Cost => Redundancy

- Definition: Introduction of spare elements to increase the circuit yield after production at the expense of overhead in area, power consumption or performance.



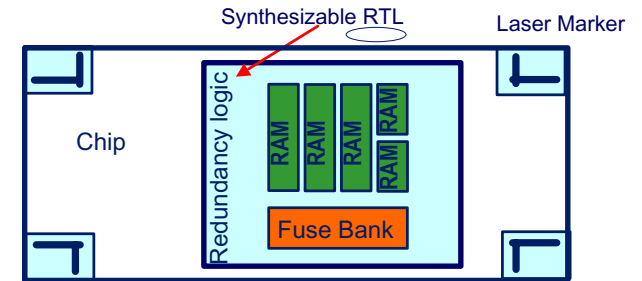
- Cost: NRE, Area, Repair & Retest
- Hard vs. Soft Redundancy: Fuses, NVM, Register storage

Manufacturing: High Yield & Low Cost => Redundancy



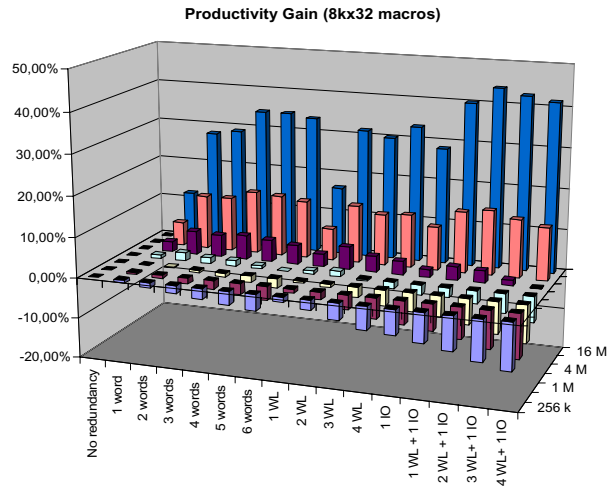
- Block Redundancy
 - + Easy to implement
 - + Bit- / Wordline fails
 - Very large area overhead
 - Single / Double Bit fails
- Row / Column Redundancy
 - + Transparent to designer
 - + Low area overhead for large mems
 - + Bit- / Wordline fails
 - Area overhead for small mems
 - Multiple Single / Double Bit fails
 - Compiler Integration non-trivial

Word-based Redundancy



- Advantages:
 - + Good yield improvement, low area overhead
 - 128 kbit: 2.5%
 - 256 kbit: 1.3%
 - from 1 Mbit on: <1%
 - + Flexible sizes
 - + One wrapper can handle multiple memories
- Disadvantage:
 - Not robust to specific fault patterns (word- / bitline faults)

Choice of Redundancy Solutions Required for Overall Optimum



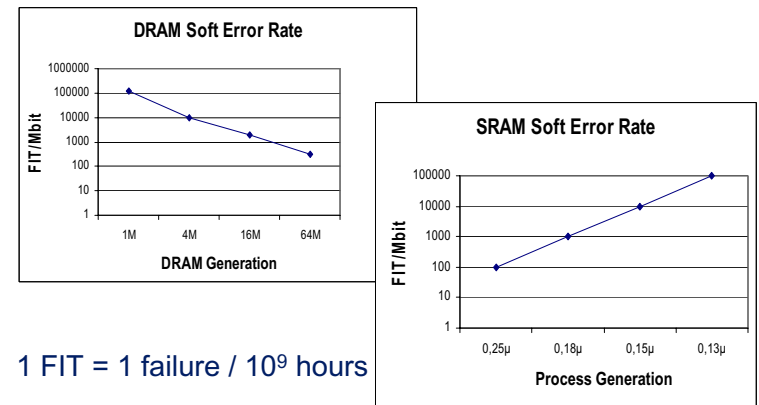
A high-quality Embedded Memory ...

- meets requirements specifications
- can be manufactured with high yield at low cost
- **can be tested economically**
 - BIST vs. Memory Tester
 - Test algorithm: coverage vs. effort
 - TDR functionality (Test, Diagnosis, Repair)
- meets reliability criteria
- enables timely product design

A high-quality Embedded Memory ...

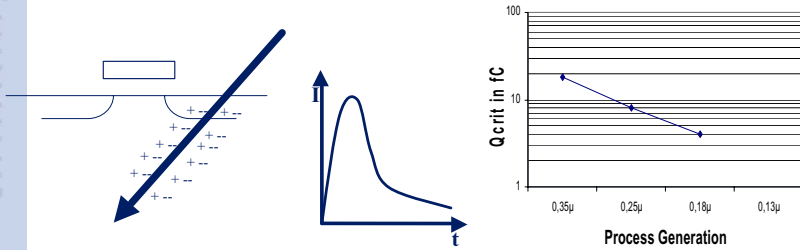
- meets requirements specifications
- can be manufactured with high yield at low cost
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- **meets reliability criteria**
 - Electromigration
 - Soft Error Rate (SER)
- enables timely product design

Radiation induced Soft Error Rate in embedded SRAMs



1 FIT = 1 failure / 10⁹ hours

What is radiation induced SER ?



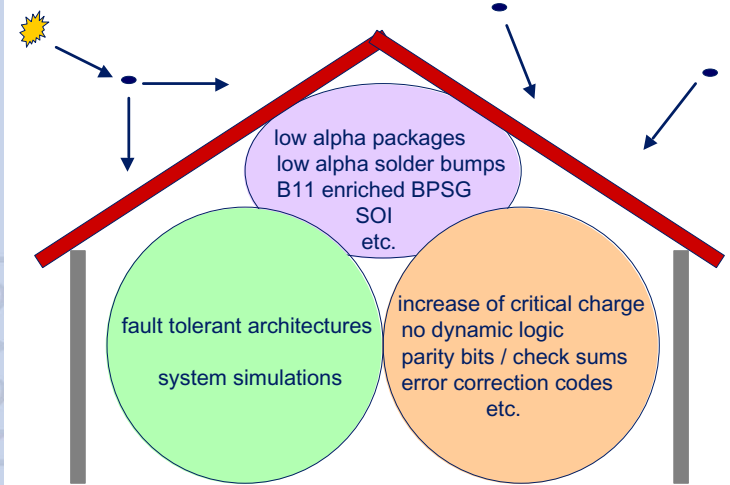
A soft error is a non-destructive error caused by alpha particles or cosmic rays

Ionizing radiation generates a current peak

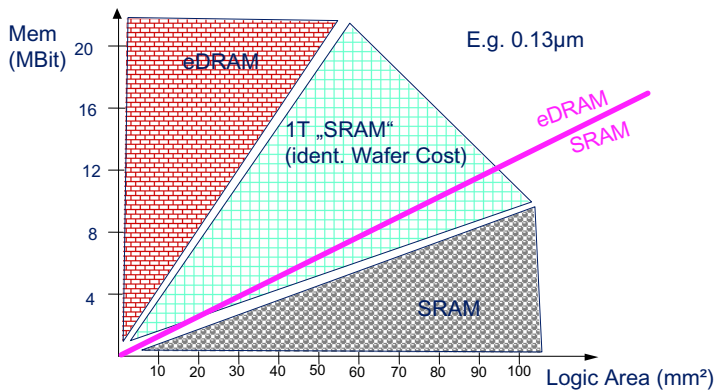
- ⇒ flips a bit without physical damage
- ⇒ significantly delays a signal

Memories and logic circuits are effected, depending on critical charge

Measures for Radiation Hard Systems



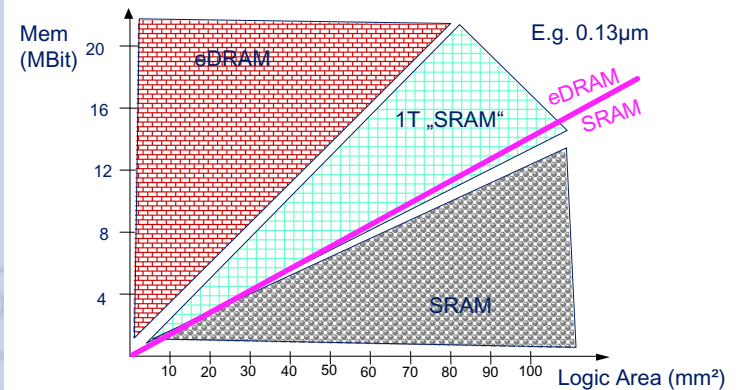
Choice of Memory Technology Depends on Many Factors



Additional Decision Factors

- Wafer Yield
- License Cost
- NRE (memory; process)
- Test cost (Burn-In?)
- Performance
- Operating Conditions
- Memory Granularity
- Availability

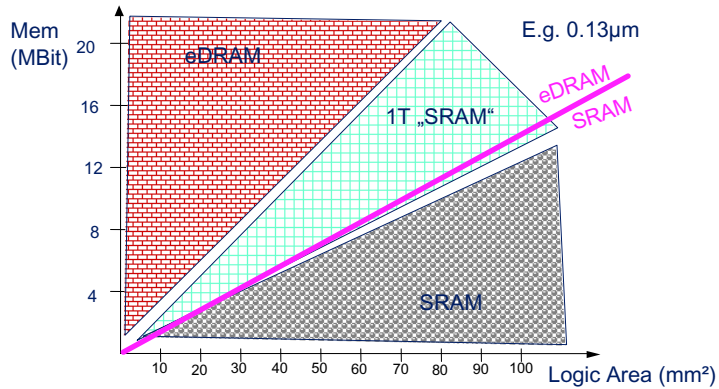
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Alternatives: SoC vs. SiP

■ MCM

■ Face-to-Face

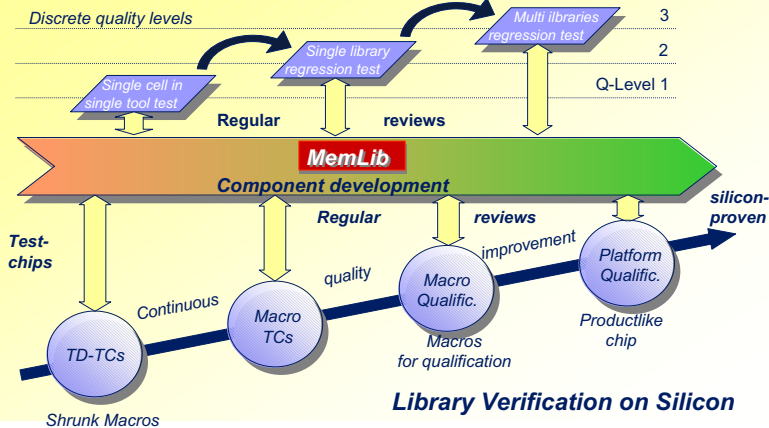
=> Directly Utilize Yield Learning of Commodity DRAM manufacturing

A high-quality Embedded Memory ...

- meets requirements specifications
- can be manufactured with high yield at low cost
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- meets reliability criteria
- enables timely product design
 - memories tightly integrated into the design flow
 - information about tradeoffs rapidly available
 - limited number of updates
 - concise information about changes for updates (tech. parameters!)

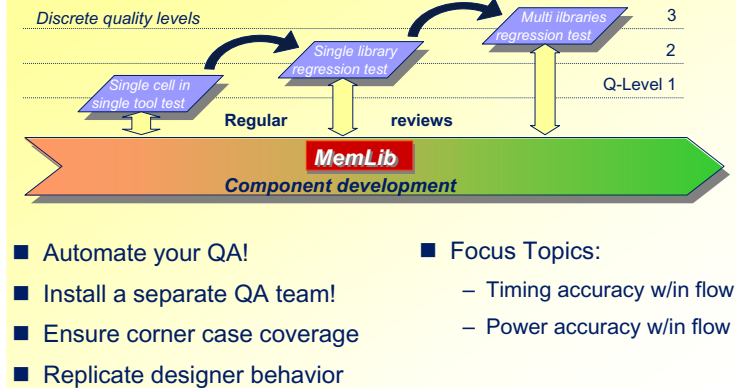
Excellent Quality Assurance - escorting the entire Development

Verification of Library Views for Design Flow



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Verification of Library Views for Design Flow



Memory Explorer

Parameter	Symbol	Unit	config1	config2	config3	config4
WordDepth	---	---	1024	1024	2048	2048
WordWidth	---	---	16	8	16	8
BottomAddress	---	---	False	False	False	False
DualAccess	---	---	Split	Split	Split	Split
Geometry	---	---	Normal	Normal	Normal	Normal
SingleBitWrite	---	---	False	False	False	False
Aspect ratio	---	---				
Memory Size	Size	bits	16384	8192	32768	16384
Width	Width	um	404.44	221	401.24	221
Height	Height	um	578	578	1062.84	1062.84
Area	Area	mm2	0.234	0.129	0.439	0.242
Density	Density	Mbits/mm2	68.445	62.629	72.978	66.249
Peak Current	I _{max}	mA	---	---	---	---
Width of the power lines	W _o	um	340	220	300	220
Average power for Read operation	P _{read}	uW/MHz	118.075	63.37	123.02	68.315
Average power for Write operation	P _{write}	uW/MHz	93.854	52.694	100.816	59.656
Average Power for Read and Write Operation	P _{avg}	uW/MHz	105.965	58.032	111.919	63.985
Average Power for Address Bus change	P _{addr}	uW/MHz	11.969	9.894	16.92	14.846
Read access time	T _{ra}	ns	3.091	3.034	3.378	3.328

■ Fast generation of datasheets for evaluations

■ Easy comparison of memory configurations

Summary

- Memory Dominance on SoCs continues to increase
- UDSM effects force changes in embedded memory design
- Memory Designers:
 - Work very closely with SoC Designers and TD / Fab people
 - Design for robustness, manufacturability, analyzability
- SoC Designers:
 - Perform reviews (concept; architecture; design)
 - Insist on detailed silicon reports
 - Ensure that manufacturability is addressed